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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Application of: Getty et al.

CASE NO.: CL2127 US NA

APPLICATION NO.: 10/817,089

GROUP ART UNIT: UNKNOWN

FILED: APRIL 2, 2004

EXAMINER: UNKNOWN

FOR: SCREENING FOR ELECTRICAL CONDUCTIVITY OF MOLECULES BY  
MEASURING SURFACE POTENTIAL

**INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner for Patents  
Washington, D.C. 20231

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Respectfully submitted,

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Application Number	10/817,089
Filing Date	April 2, 2004
First Named Inventor	Getty et al.
Group Art Unit	Unknown
Examiner Name	Unknown
Attorney Docket Number	CL2127 US NA

Sheet	1	of	3
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Examiner Signature		Date Considered	
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**OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS**

Examiner Initials *	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
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